L Number	Hits	Search Text	DB	Time stamp
1	5	5993141.URPN.	USPAT	2003/07/28 08:23
5	5	5993141.URPN.	USPAT	2003/07/28 08:23
6	221	(414/\$.ccls. 118/\$.ccls. 156/345.\$.ccls.)	USPAT;	2003/07/28 08:25
	221	and (articulat\$3 same linear\$3)	US-PGPUB	2000,01,20 00120
7	151	(414/\$.ccls. 118/\$.ccls. 156/345.\$.ccls.)	USPAT;	2003/07/28 08:28
'	131	and (articulat\$3 same linear\$3 same (hand	US-PGPUB	2003/01/20 00.20
		robot arm effector blade))	U3-FGFUB	
	116		II C D D M	2003/07/28 08:27
8	116	(414/\$.ccls. 118/\$.ccls. 156/345.\$.ccls.)	USPAT;	2003/01/28 08:21
		and (articulat\$3 with linear\$3)	US-PGPUB	0000/07/00 00 07
9	68	((414/\$.ccls. 118/\$.ccls. 156/345.\$.ccls.)	USPAT;	2003/07/28 08:27
		and (articulat\$3 same linear\$3 same (hand	US-PGPUB	
		robot arm effector blade))) not		
		((414/\$.ccls. 118/\$.ccls. 156/345.\$.ccls.)		
		and (articulat\$3 with linear\$3) )		,
13	0	(c23c016\$.ipc.) and (articulat\$3 same	EPO; JPO;	2003/07/28 08:31
		linear\$3 same (hand robot arm effector	DERWENT	
		blade))		
14	0	(c23c016\$.ipc.) and (articulat\$3 same	EPO; JPO;	2003/07/28 08:29
		linear\$3 same (hand robot arm effector	DERWENT	
		blade))		
15	10	(c23c016\$.ipc.) and (linear\$3 same (hand	EPO; JPO;	2003/07/28 08:29
		robot arm effector blade))	DERWENT	2000,01,20 00.29
16	213	(articulat\$3 same linear\$3 same (hand	EPO; JPO;	2003/07/28 08:31
*	213	robot arm effector blade))	DERWENT	2003/07/20 00:31
17	3	(articulat\$3 same linear\$3 same (hand		2003/07/20 00 40
1 /	)		EPO; JPO;	2003/07/28 08:40
		robot arm effector blade) same (wafer	DERWENT	
1.0		substrate semiconductor))		
18	70	((reciprocat\$5 extend\$3 retract\$4) same	EPO; JPO;	2003/07/28 08:41
j l		linear\$3 same (hand robot arm effector	DERWENT	
		blade) same (wafer substrate		
		semiconductor))		
20	654	((reciprocat\$5 extend\$3 retract\$4) same	USPAT;	2003/07/28 09:01
i		linear\$3 same (hand robot arm effector	US-PGPUB	
		blade) same (wafer substrate		
		semiconductor))		
19	70	((reciprocat\$5 extend\$3 retract\$4) same	EPO; JPO;	2003/07/28 08:41
		linear\$3 same (hand robot arm effector	DERWENT	
		blade) same (wafer substrate		
		semiconductor))		
21	172	((reciprocat\$5 extend\$3 retract\$4) with	USPAT;	2003/07/28 09:52
	1.5	linear\$3 with (hand robot arm effector	US-PGPUB	2003/07/20 03:32
		blade) same (wafer substrate	55 10101	
		semiconductor))		
22	25	4907931.URPN.	USPAT	2003/07/28 09:21
23	25	4907931.0RPN.   ("3503527"   "4103232"   "4407627"		
			USPAT	2003/07/28 10:37
		"4441853"   "4457664"   "4655584"     "4695215"   "4746256"   "4752898").PN.		
24	3.5	, , , , , , , , , , , , , , , , , , , ,	II.C.D.A.M.	2002/07/20 02 02
24	25	4695215.URPN.	USPAT	2003/07/28 09:26
25	13	(("4552504") or ("4654106") or ("4908095")	USPAT;	2003/07/28 10:47
		or ("5011366") or ("5064340") or	US-PGPUB	
ļ		("5306380") or ("5655060") or ("5746565")		
		or ("5823736") or ("5989346") or		
j l		("6051101") or ("6155768") or		
		("6164894")).PN.		
26	11	5306380.URPN.	USPAT	2003/07/28 09:55
27	13	5823736.URPN.	USPAT	2003/07/28 10:40
28	8	("3817402"   "4591044"   "4776745"	USPAT	2003/07/28 10:42
		"5197089"   "5345639"   "5374147"		1
] 1		"5445491"   "5540535").PN.		
29	29	414/609.ccls. and (wafer semiconductor	USPAT;	2003/07/28 10:58
	,	substrate)	US-PGPUB	
30	0	6331095.URPN.	USPAT	2003/07/28 10:54
31	7	("4816098"   "5823736"   "5879128"	USPAT	2003/07/28 10:54
	, '	"5879460"   "5883017"   "5934856"	JULIAI	2000,07,20 10.54
		5079400   5005017   5954050   "5989346").PN.		
32	0		IICDAM.	2002/07/28 10-50
ا ا	U	414/.222.04.ccls. and (wafer semiconductor	USPAT;	2003/07/28 10:59
22		substrate)	US-PGPUB	0000/05/00 55 55
33	21	414/222.04.ccls. and (wafer semiconductor	USPAT;	2003/07/28 10:59
_		substrate)	US-PGPUB	
34	7	414/222.05.ccls. and (wafer semiconductor	USPAT;	2003/07/28 11:00
		substrate)	US-PGPUB	]

35	8	414/222.06.ccls. and (wafer semiconductor	USPAT;	2003/07/28 11:00
		substrate)	US-PGPUB	
36	34	(414/222.04.ccls. and (wafer semiconductor	USPAT;	2003/07/28 11:00
		substrate)) (414/222.05.ccls. and (wafer	US-PGPUB	
		semiconductor substrate))		
		(414/222.06.ccls. and (wafer semiconductor		
		substrate))	-	
-	116		USPAT;	2003/07/28 08:27
		and (articulat\$3 with linear\$3)	US-PGPUB	
_	54	1 (	USPAT;	2003/07/27 19:29
		linear\$3 with extend\$3)	US-PGPUB	
_	1	("5993141").PN.	USPAT;	2003/07/28 08:23
	_	5000141	US-PGPUB	
_	5		USPAT	2003/07/28 08:23
_	28	("4009785"   "4410209"   "4566726"	USPAT	2003/07/27 19:30
		"4601627"   "4775281"   "4875824"		
		"5080549"   "5100502"   "5147175"		
	i	"5286296"   "5382128"   "5439547"		
		"5474410"   "5479108"   "5562387"		
		"5636963"   "5647626"   "5647724"		
		"5669644"   "5697749"   "5755469"     "5789878"   "5900105"   "5950495"		
		"5789878"   "5900105"   "5950495"     "5993141"   "6048162"   "6073366"		
		"6224319").PN.		
	_	0224J1J /.EN.	L	